

Docket No.: 57454-994

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Takeshi SATOH, et al.	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: January 05, 2004	:	Examiner: Unknown
	:	
For: POROUS Si3 N4 AND PRODUCING METHOD THEREOF	:	

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of the references listed on attached Form 1449 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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Date: January 5, 2004

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)						ATTY. DOCKET NO. 57454-994		SERIAL NO.			
						APPLICANT Takeshi SATOH, et al.					
						FILING DATE January 05, 2004			GROUP		
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (<i>if known</i>)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear					
		US	2001/0036531 A1	11/01/2001	Shinohara et al.	Corresponds to Japanese Patent Application No. 2001-316188					
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FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number + -Kind Codes (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation					
						Yes	No				
		JP P2001-316188A	11/13/2001	ASAHI GLASS CO LTD		(Japan w/English Abstract)					
		EP 0 653 392 A1	05/17/1995	SUMITOMO ELECTRIC INDUSTRIES, LTD	Corresponds to WO 94/27929	X					
		WO 94/27929		SUMITOMO ELECTRIC INDUSTRIES, LTD.		(w/English Abstract)					
		EP 1 298 110 A1	04/02/2003	NGK INSULATORS, LTD.	Corresponds to Japanese Laying-Open No. 2002-284586	X					
		JP P2002-284586A	10/03/2002	NGK INSULATORS LTD		(Japan w/English Abstract)					
- OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.									
EXAMINER				DATE CONSIDERED							

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.